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***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

Applicant: Tatsuo YAMAGUCHI et al.  
Title: METHOD AND APPARATUS FOR  
MEASUREMENT AND CORRECTION OF  
REFRACTIVE POWER DISTRIBUTION DATA  
Appl. No.: 10/525,321  
International Filing Date: 8/25/2003  
371(c) Date: 2/22/2005  
Examiner: James R. Greece  
Art Unit: 2873  
Confirmation Number: 5370

**AMENDMENT AND REPLY UNDER 37 CFR 1.111**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

This communication is responsive to the Non-Final Office Action dated November 14, 2008, concerning the above-referenced patent application.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this document.

**Remarks/Arguments** begin on page 8 of this document.

Please amend the application as follows: